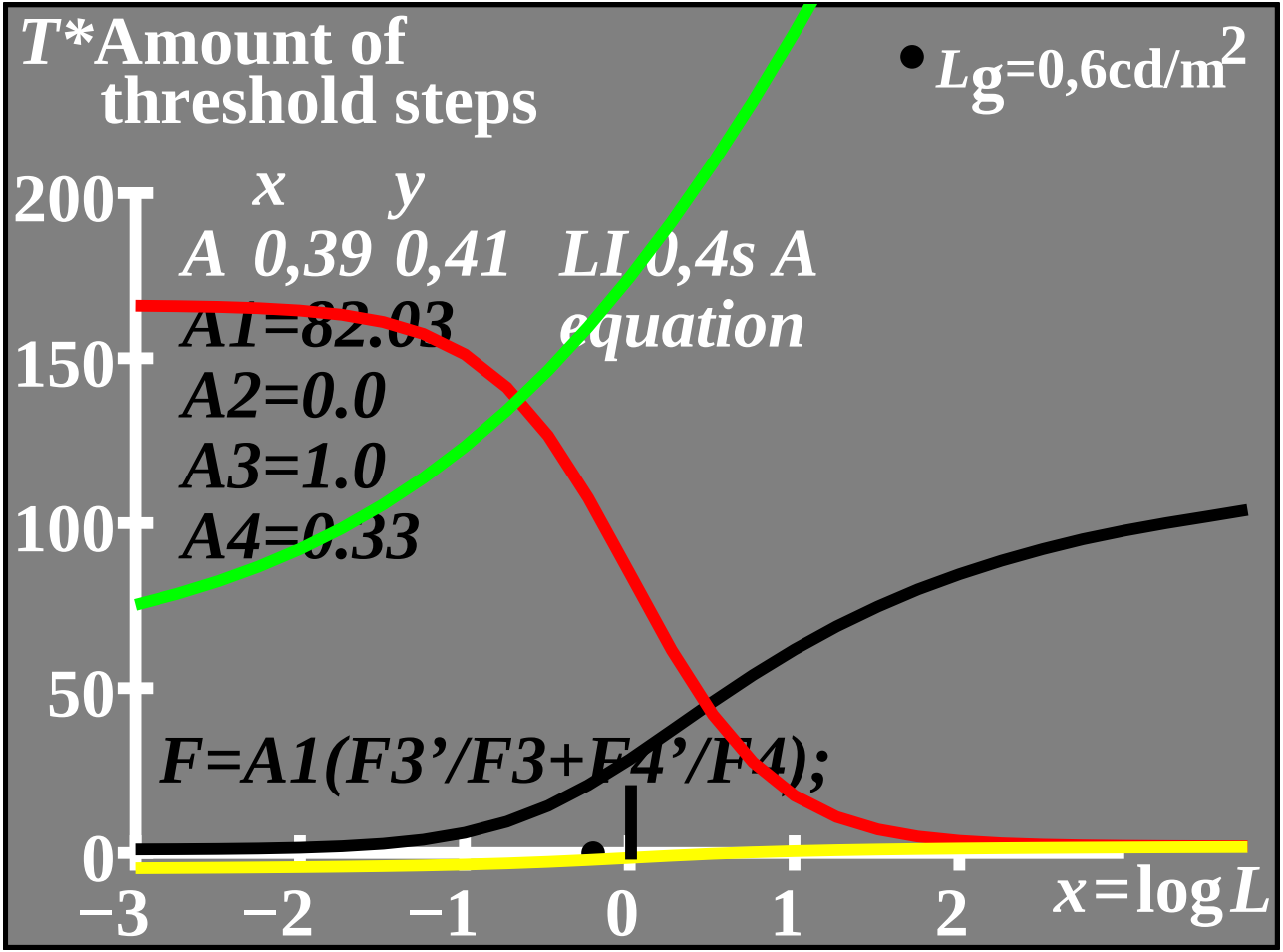
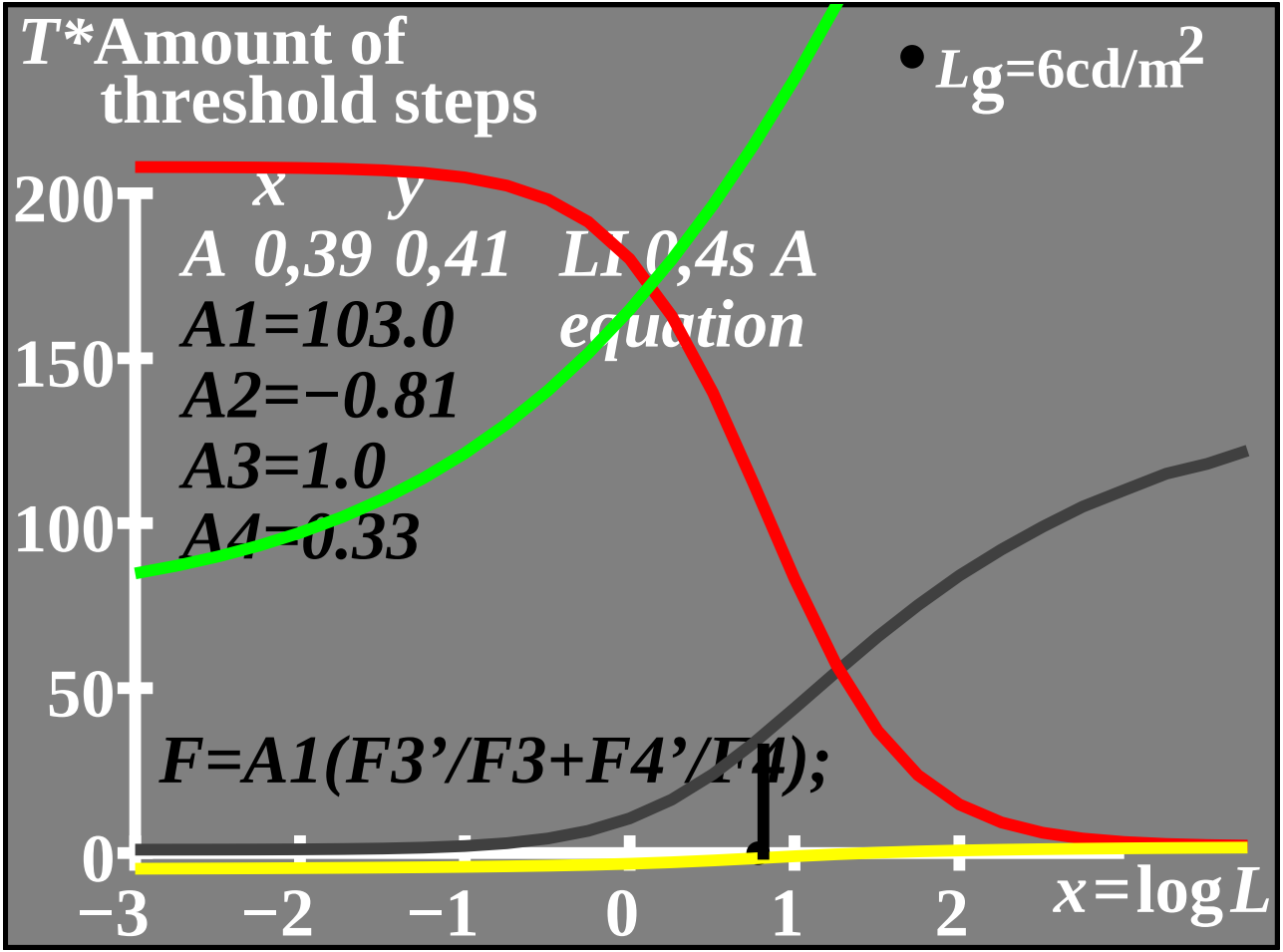
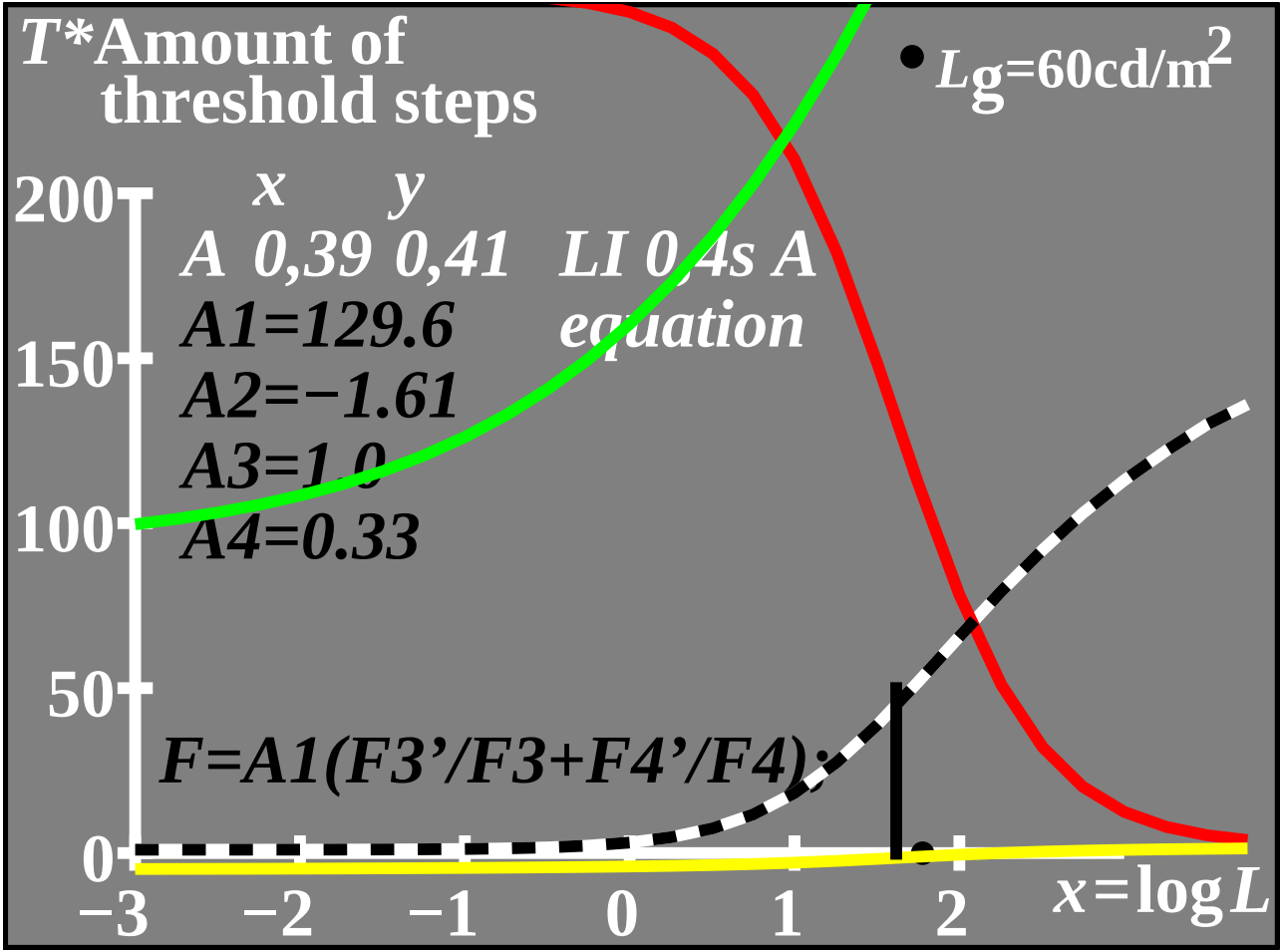

T*Amount of threshold steps
Lg=0,6cd/m2
x y
A 0,39 0,41 LI 0,4s A
A1=82.03
A2=0.0
A3=1.0
A4=0.33
equation
F=A1(F3'/F3+F4'/F4);
200
150
100
50
0
−3 −2 −1 0 1 2
x=log L

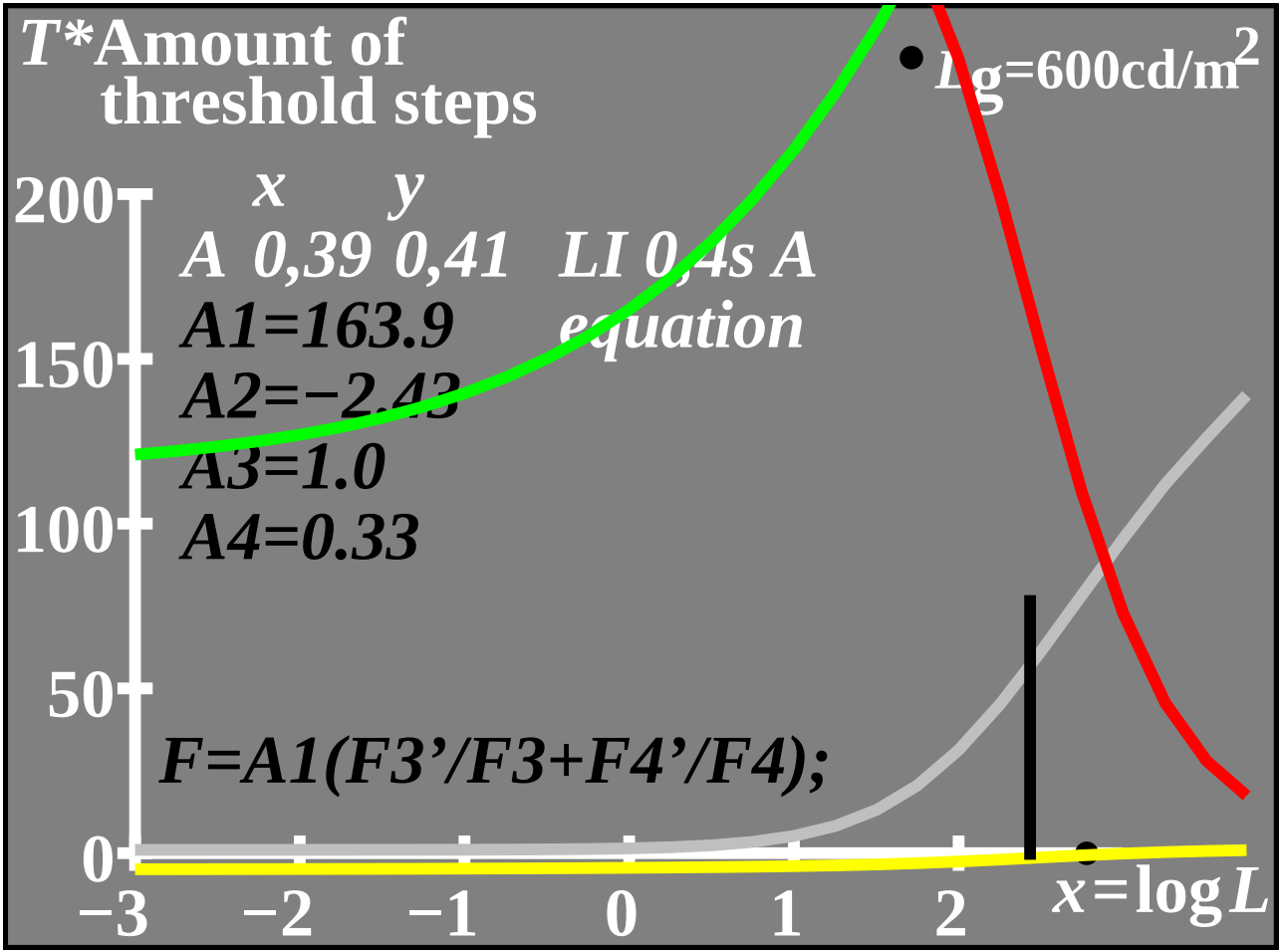
TE571−8A_1


T*Amount of threshold steps
Lg=6cd/m2
200
150
100
50
0
x y
A 0,39 0,41 LI 0,4s A
A1=103.0
A2=−0.81
A3=1.0
A4=0.33
equation
F=A1(F3'/F3+F4'/F4);
−3
−2
−1
0
1
2
x=log L

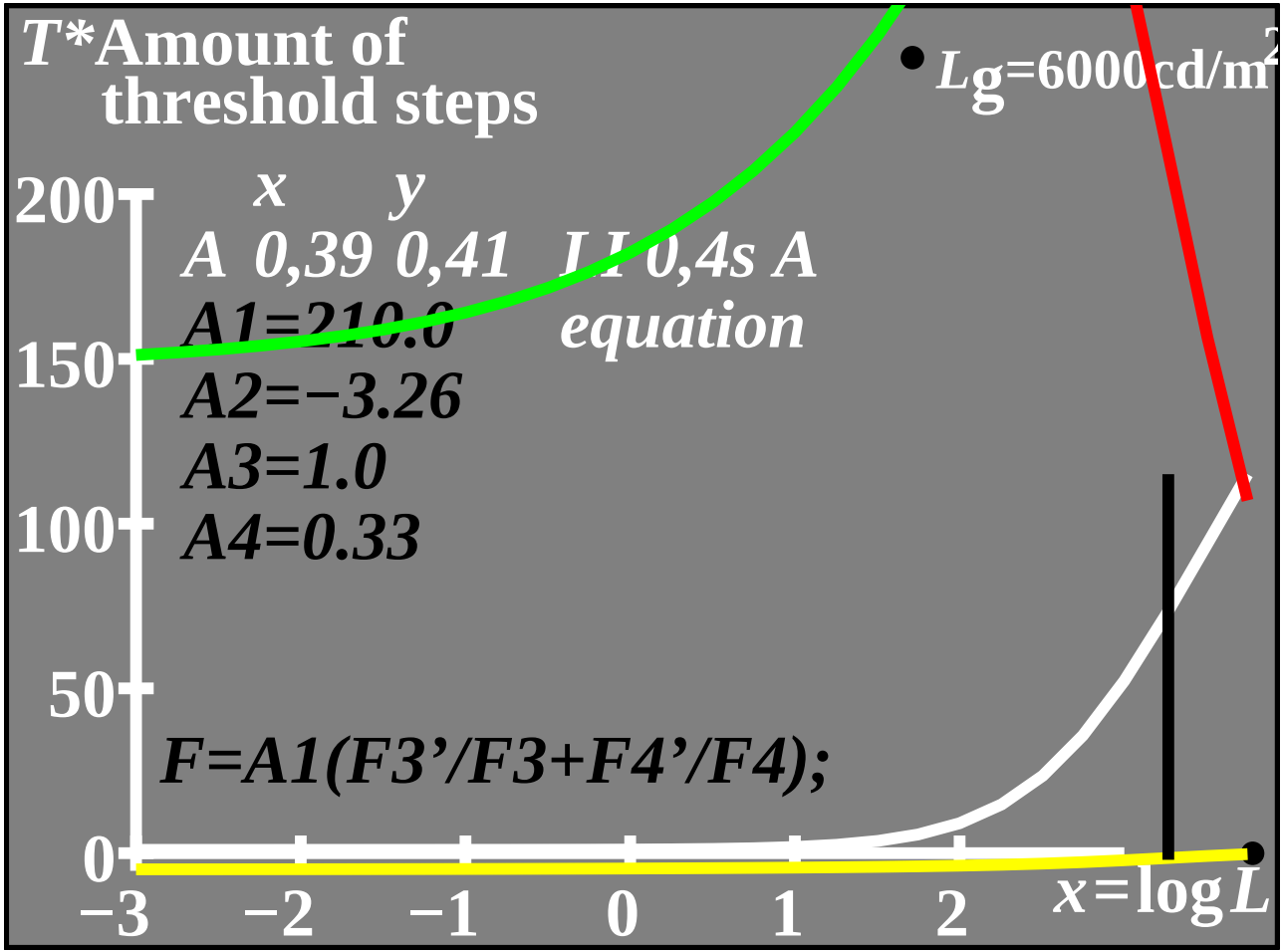
TE571−8A_2


T*Amount of threshold steps
Lg=60cd/m2
200
150
100
50
0
x y
A 0,39 0,41 LI 0,4s A
A1=129.6
A2=−1.61
A3=1.0
A4=0.33
equation
F=A1(F3'/F3+F4'/F4);
−3
−2
−1
0
1
2
x=log L

TE571−8A_3


T*Amount of threshold steps
Lg=600cd/m2
x y
A 0,39 0,41 LI 0,4s A
A1=163.9
A2=−2.43
A3=1.0
A4=0.33
equation
F=A1(F3'/F3+F4'/F4);
200
150
100
50
0
−3 −2 −1 0 1 2
x=log L

TE571−8A_4


T*Amount of threshold steps
Lg=6000cd/m2
200
150
100
50
0
x y
A 0,39 0,41 I I 0,4s A
A1=210.0
A2=−3.26
A3=1.0
A4=0.33
equation
F=A1(F3'/F3+F4'/F4);
−3
−2
−1
0
1
2
x=log L

TE571−8A_5